

Search Notes

Application/Control No.

10/728,847

Examiner

Mohamed Charioui

Applicant(s)/Patent under
Reexamination

SHIMIZU ET AL.

Art Unit

2857

SEARCHED

| Class | Subclass | Date | Examiner |
|--------|--------------------------------|------------|----------|
| 702 | 62, 81-84, 115, 122, 132 | 5/12/2004 | MC |
| 702 | 136, 188 | 5/12/2004 | MC |
| 702 | 182-187 | 5/12/2004 | MC |
| 702 | 30-32 | 5/12/2004 | MC |
| 700 | 287 | 5/12/2004 | MC |
| 376 | 215 | 5/12/2004 | MC |
| 714 | 25 | 5/13/2004 | MC |
| Search | updated | 12/12/2004 | MC |
| 700 | 26 | 12/12/2004 | MC |
| Search | updated | 6/22/2005 | MC |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|------|----------|
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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
|---|------------|------|
| East: ("power plant" or ((nuclear or industrial) near (plant or power))) near (maintenance or monitor\$) | 5/12/2004 | MC |
| East: ("power plant" or (nuclear or industrial)) near (maintenance or monitoring or monitored or monitors) | 5/12/2004 | MC |
| East: ("power plant" or (nuclear or industrial)) near ((remote or remotely) near (maintenance or monitor\$)) | 5/13/2004 | MC |
| IEEE: search by Inventor's name | 5/13/2004 | MC |
| IEEE: (basic search): ((maintenance or monitoring) near (power or nuclear or industrial))with (remote or remotely) | 5/13/2004 | MC |
| Search updated | 12/12/2004 | MC |
| Search updated | 6/22/2005 | MC |
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